

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Dalton et al.

Application No.: 10/772,109

Filed: February 3, 2004

Title: USE OF METALLOCENES TO INHIBIT
COPPER OXIDATION DURING
SEMICONDUCTOR PROCESSING

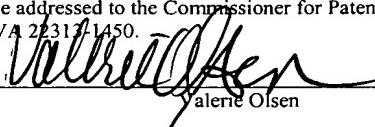
Attorney Docket No.:
NOVLP082/NVLS-2893

Examiner: Jarrett Stark

Group: 2823

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as first-class mail on February 15, 2007 in an envelope addressed to the Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450.

Signed: 

Valerie Olsen

AMENDMENT D

Mail Stop RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This is in response to the Office Action dated November 16, 2006 and accompanies a Request for Continued Examination. Please amend the above-identified patent application as follows:

Amendments to the Claims begin on page 2 of this paper.

Remarks/Arguments beginning on page 5 of this paper.